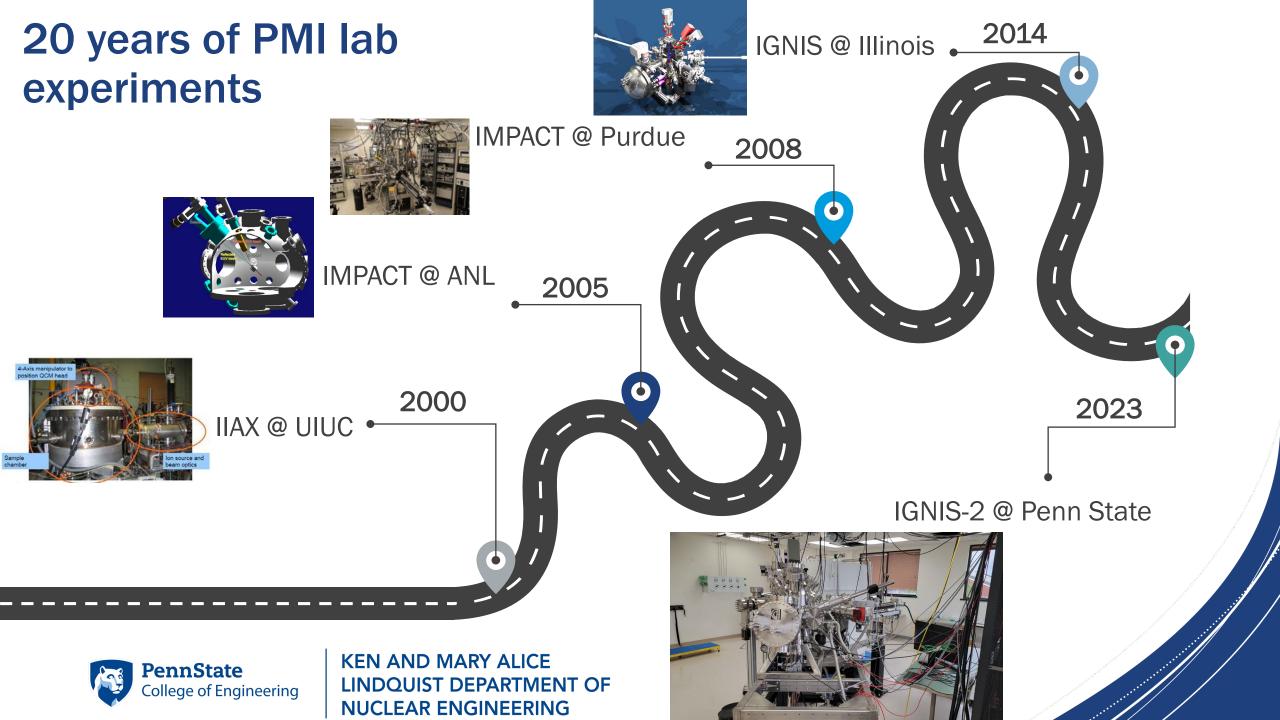
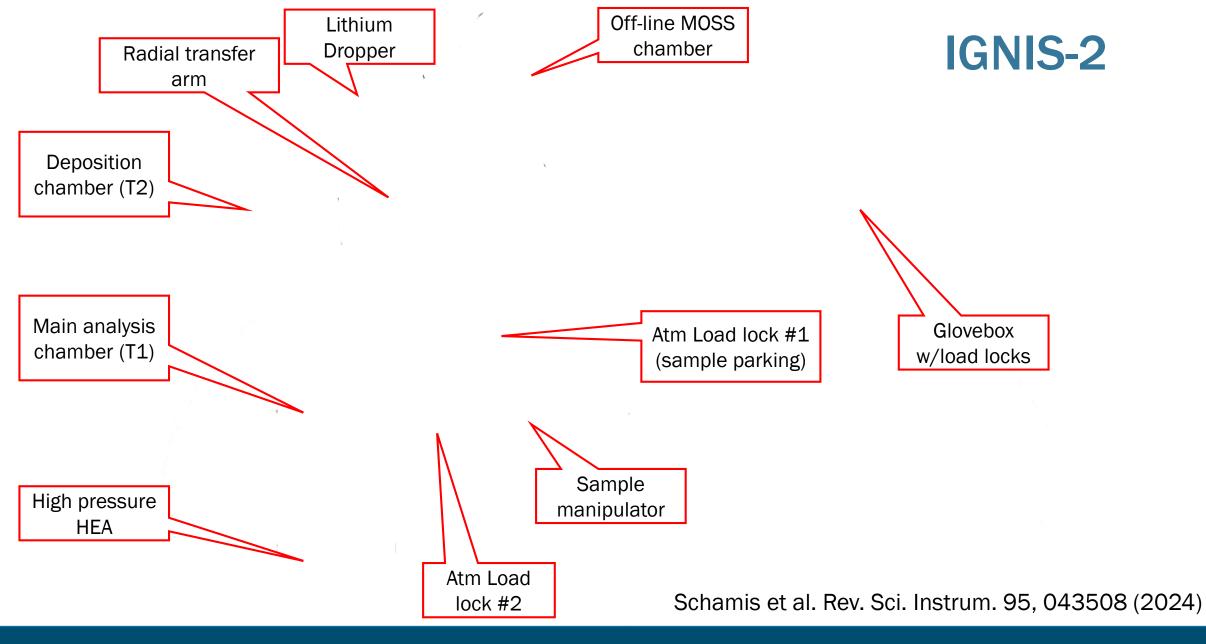
Multi-species materials sputtering studies in IGNIS-2

M. Nieto-Perez and the EMPIRES team

RIAL-PLASMA INTERACTION AND RADIATION EFFECTS ON SURFACES









How can IGNIS-2 contribute to D-IIID wall change program?

- Advanced surface characterization station with exposure to plasma and gas (10 mTorr).
- Sample temperatures up to 850 °C.
- Sputtering yield measurements for pure and multicomponent materials (more on next slide).
- Strain measurements using laser reticule (MOSS)



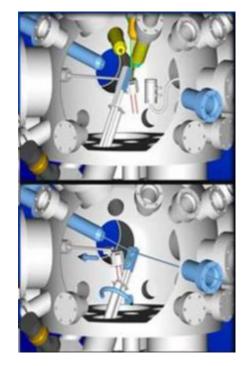
Sputtering measurements on multi-atom targets

- A very relevant example for DIII-D is SiC.
- Questions:
 - Are Si and C partial sputter yields known? Are angular sputter distributions known? Are they the same for both Si and C?
 - How does the sputter yield change with temperature?
 - How is SiC surface composition evolving during ion bombardment?
- Some of these questions can be answered on IGNIS-2!

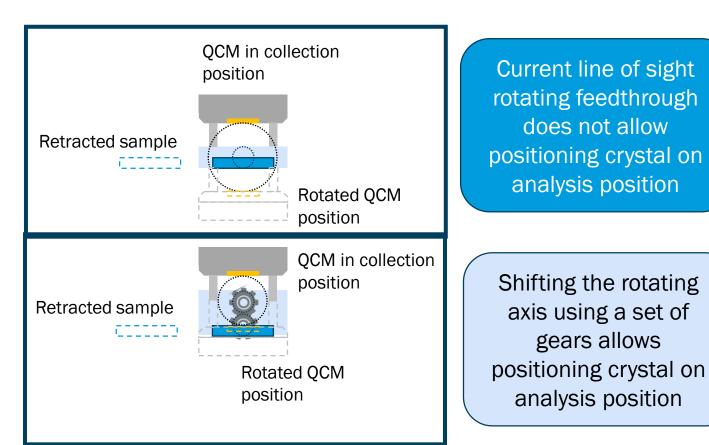


RAMPSY

• Rotating Assembly for Measurement of Partial Sputtering Yield



Successfully implemented on IMPACT in 2004, but never formally documented



PennState College of Engineering

RAMPSY Design

